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CONFIRMATION NO. 7384

<b>SERIAL NUMBER</b> 10/825,033	<b>FILING OR 371(c) DATE</b> 04/14/2004 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2812	<b>ATTORNEY DOCKET NO.</b> 12844.15USD1
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## APPLICANTS

Yoshikazu Fujimori, Kyoto-shi, JAPAN;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a DIV of 10/218,988 08/13/2002 PAT 6,740,532 KL

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2001-246070 08/14/2001 KL

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 06/26/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 5	<b>TOTAL CLAIMS</b> 7	<b>INDEPENDENT CLAIMS</b> 5
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature: <u>[Signature]</u> Initials: KL				

## ADDRESS

23552

## TITLE

Method of manufacturing ferroelectric substance thin film and ferroelectric memory using the ferroelectric substance thin film

<b>FILING FEE RECEIVED</b> 942	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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